- (3) For units with a main stack and bypass stack configuration, Hg emission testing shall be performed only on the main stack. For reporting purposes, the default Hg concentration used for the main stack shall either be the highest value obtained in any test run for that stack or 0.50 μ gm/scm, whichever is greater. Whenever the main stack is bypassed, the maximum potential Hg concentration, as defined in section 2.1.7 of appendix A to this part, shall be reported.
- (f) At the end of each calendar year, if the cumulative annual Hg mass emissions from an affected unit have exceeded 464 ounces, then the owner shall install, certify, operate, and maintain a Hg concentration monitoring system or a sorbent trap monitoring system no later than 180 days after the end of the calendar year in which the annual Hg mass emissions exceeded 464 ounces. For common stack and multiple stack configurations, installation and certification of a Hg concentration or sorbent trap monitoring system on each stack (except for bypass stacks) is likewise required within 180 days after the end of the calendar year, if:
- (1) The annual Hg mass emissions at the common stack have exceeded 464 ounces times the number of affected units using the common stack; or
- (2) The sum of the annual Hg mass emissions from all of the multiple stacks or ducts has exceeded 464 ounces; or
- (3) The sum of the annual Hg mass emissions from the main and bypass stacks has exceeded 464 ounces.
- (g) For an affected unit that is using a Hg concentration CEMS or a sorbent trap system under §75.81(a) to continuously monitor the Hg mass emissions, the owner or operator may switch to the methodology in §75.81(b), provided that the applicable conditions in paragraphs (c) through (f) of this section are met.

§ 75.82 Monitoring of Hg mass emissions and heat input at common and multiple stacks.

(a) Unit utilizing common stack with other affected unit(s). When an affected unit utilizes a common stack with one or more affected units, but no non-af-

fected units, the owner or operator shall either:

- (1) Install, certify, operate, and maintain the monitoring systems described in §75.81(a) at the common stack, record the combined Hg mass emissions for the units exhausting to the common stack. Alternatively, if, in accordance with §75.81(e), each of the units using the common stack is demonstrated to emit less than 464 ounces of Hg per year, the owner or operator may install, certify, operate and maintain the monitoring systems and perform the Hg emission testing described under §75.81(b). If reporting of the unit heat input rate is required, determine the hourly unit heat input rates either by:
- (i) Apportioning the common stack heat input rate to the individual units according to the procedures in §75.16(e)(3); or
- (ii) Installing, certifying, operating, and maintaining a flow monitoring system and diluent monitor in the duct to the common stack from each unit; or
- (2) Install, certify, operate, and maintain the monitoring systems and (if applicable) perform the Hg emission testing described in §75.81(a) or §75.81(b) in the duct to the common stack from each unit.
- (b) *Unit utilizing common stack with nonaffected unit(s)*. When one or more affected units utilizes a common stack with one or more nonaffected units, the owner or operator shall either:
- (1) Install, certify, operate, and maintain the monitoring systems and (if applicable) perform the Hg emission testing described in §75.81(a) or §75.81(b) in the duct to the common stack from each affected unit; or
- (2) Install, certify, operate, and maintain the monitoring systems described in §75.81(a) in the common stack; and
- (i) Install, certify, operate, and maintain the monitoring systems and (if applicable) perform the Hg emission testing described in §75.81(a) or §75.81(b) in the duct to the common stack from each non-affected unit. The designated representative shall submit a petition to the permitting authority and the Administrator to allow a method of calculating and reporting the Hg mass emissions from the affected units as

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the difference between Hg mass emissions measured in the common stack and Hg mass emissions measured in the ducts of the non-affected units, not to be reported as an hourly value less than zero. The permitting authority and the Administrator may approve such a method whenever the designated representative demonstrates, to the satisfaction of the permitting authority and the Administrator, that the method ensures that the Hg mass emissions from the affected units are not underestimated; or

(ii) Count the combined emissions measured at the common stack as the Hg mass emissions for the affected units, for recordkeeping and compliance purposes, in accordance with paragraph (a) of this section; or

(iii) Submit a petition to the permitting authority and the Administrator to allow use of a method for apportioning Hg mass emissions measured in the common stack to each of the units using the common stack and for reporting the Hg mass emissions. The permitting authority and the Administrator may approve such a method whenever the designated representative demonstrates, to the satisfaction of the permitting authority and the Administrator, that the method ensures that the Hg mass emissions from the affected units are not underestimated.

(c) Unit with a main stack and a bypass stack. Whenever any portion of the flue gases from an affected unit can be routed through a bypass stack to avoid the Hg monitoring system(s) installed on the main stack, the owner and operator shall either:

(1) Install, certify, operate, and maintain the monitoring systems described in §75.81(a) on both the main stack and the bypass stack and calculate Hg mass emissions for the unit as the sum of the Hg mass emissions measured at the two stacks:

(2) Install, certify, operate, and maintain the monitoring systems described in §75.81(a) at the main stack and measure Hg mass emissions at the bypass stack using the appropriate reference methods in §75.22(b). Calculate Hg mass emissions for the unit as the sum of the emissions recorded by the installed monitoring systems on the main stack and the emissions meas-

ured by the reference method monitoring systems; or

(3) Install, certify, operate, and maintain the monitoring systems and (if applicable) perform the Hg emission testing described in §75.81(a) or §75.81(b) only on the main stack. If this option is chosen, it is not necessary to designate the exhaust configuration as a multiple stack configuration in the monitoring plan required under §75.53, since only the main stack is monitored. For each unit operating hour in which the bypass stack is used, report, as applicable, the maximum potential Hg concentration (as defined in section 2.1.7 of appendix A to this part), and the appropriate substitute data values for flow rate, CO₂ concentration, O₂ concentration, and moisture (as applicable), in accordance with the missing data procedures of §§ 75.31 through 75.37.

(d) Unit with multiple stack or duct configuration. When the flue gases from an affected unit discharge to the atmosphere through more than one stack, or when the flue gases from an affected unit utilize two or more ducts feeding into a single stack and the owner or operator chooses to monitor in the ducts rather than in the stack, the owner or operator shall either:

(1) Install, certify, operate, and maintain the monitoring systems and (if applicable) perform the Hg emission testing described in §75.81(a) or §75.81(b) in each of the multiple stacks and determine Hg mass emissions from the affected unit as the sum of the Hg mass emissions recorded for each stack. If another unit also exhausts flue gases into one of the monitored stacks, the owner or operator shall comply with the applicable requirements of paragraphs (a) and (b) of this section, in order to properly determine the Hg mass emissions from the units using that stack; or

(2) Install, certify, operate, and maintain the monitoring systems and (if applicable) perform the Hg emission testing described in § 75.81(a) or § 75.81(b) in each of the ducts that feed into the stack, and determine Hg mass emissions from the affected unit using the sum of the Hg mass emissions measured at each duct, except that where another unit also exhausts flue gases to one or more of the stacks, the owner

or operator shall also comply with the applicable requirements of paragraphs (a) and (b) of this section to determine and record Hg mass emissions from the units using that stack.

§75.83 Calculation of Hg mass emissions and heat input rate.

The owner or operator shall calculate Hg mass emissions and heat input rate in accordance with the procedures in sections 9.1 through 9.3 of appendix F to this part.

§75.84 Recordkeeping and reporting.

- (a) General recordkeeping provisions. The owner or operator of any affected unit shall maintain for each affected unit and each non-affected unit under §75.82(b)(2)(ii) a file of all measurements, data, reports, and other information required by this part at the source in a form suitable for inspection for at least 3 years from the date of each record. Except for the certification data required in §75.57(a)(4) and the initial submission of the monitoring plan required in §75.57(a)(5), the data shall be collected beginning with the earlier of the date of provisional certification or the compliance deadline in §75.80(b). The certification data required in §75.57(a)(4) shall be collected beginning with the date of the first certification test performed. The file shall contain the following information:
- (1) The information required in $\S 75.57(a)(2)$, (a)(4), (a)(5), (a)(6), (b), (c)(2), (g) (if applicable), (h), and (i) or (j) (as applicable). For the information in $\S 75.57(a)(2)$, replace the phrase "the deadline in $\S 75.4(a)$, (b) or (c)" with the phrase "the applicable certification deadline under the State or Federal Hg mass emission reduction program";
- (2) The information required in §75.58(b)(3), for units with flue gas desulfurization systems or add-on Hg emission controls;
- (3) For affected units using Hg CEMS or sorbent trap monitoring systems, for each hour when the unit is operating, record the Hg mass emissions, calculated in accordance with section 9 of appendix F to this part.
- (4) Heat input and Hg methodologies for the hour; and

- (5) Formulas from monitoring plan for total Hg mass emissions and heat input rate (if applicable);
- (b) Certification, quality assurance and quality control record provisions. The owner or operator of any affected unit shall record the applicable information in §75.59 for each affected unit or group of units monitored at a common stack and each non-affected unit under §75.82(b)(2)(ii).
- (c) Monitoring plan recordkeeping provisions. (1) General provisions. The owner or operator of an affected unit shall prepare and maintain a monitoring plan for each affected unit or group of units monitored at a common stack and each non-affected unit under §75.82(b)(2)(ii). The monitoring plan shall contain sufficient information on the continuous monitoring systems and the use of data derived from these systems to demonstrate that all the unit's Hg emissions are monitored and reported.
- (2) Updates. Whenever the owner or operator makes a replacement, modification, or change in a certified continuous monitoring system or alternative monitoring system under subpart E of this part, including a change in the automated data acquisition and handling system or in the flue gas handling system, that affects information reported in the monitoring plan (e.g., a change to a serial number for a component of a monitoring system), then the owner or operator shall update the monitoring plan.
- (3) Contents of the monitoring plan. Each monitoring plan shall contain the information in §75.53(e)(1) in electronic format and the information in §75.53(e)(2) in hardcopy format.
- (d) General reporting provisions. (1) The designated representative for an affected unit shall comply with all reporting requirements in this section and with any additional requirements set forth in an applicable State or Federal Hg mass emission reduction program that adopts the requirements of this subpart.
- (2) The designated representative for an affected unit shall submit the following for each affected unit or group of units monitored at a common stack and each non-affected unit under §75.82(b)(2)(ii):